IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	U.S. Patent Application of)
HATA	ANO et al.)
Appli	ication Number: To be Assigned)
Filed:	: Concurrently Herewith)
For:	METHOD FOR FABRICATING IMAGE DISPLAY DEVICE)
Атто	PRNEY DOCKET NO. HITA.0407)

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §§ 1.56 and 1.97, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. Any other documents or information submitted for consideration by the Examiner are listed in this paper. A copy of each U.S. and foreign patent, or each publication or portion thereof listed or herein identified, is submitted herewith.

This Information Disclosure Statement is submitted with the initial filing of the application. Accordingly, no fee is due or payable at this time.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

Please charge any additional fees or credit any overpayments in connection with this paper to Deposit Account No. 08-1480.

Respectfully submitted,

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June 25, 2003

Form PTO 1449		ATTY. DOCKET NUMBER HITA.0407		1	Serial Number To be Assigned			
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Information Disclosure Statement by Applicant		Concurrently Herewith		GKOOP				
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		Foreign Pat	tent Documents					
Examiner	DOCUMENT NUMBER	FILING DATE	COUNTRY	CLASS	Sub-	TRANSLA	ATION	
Initial					CLASS	YES	No	
	2002-43222	2/21/95	Japan			Abstract	X	
	2002-100637	2/21/95	Japan			Abstract	X	
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	Other Doc	cuments (Including	Author Title Date [Pertinent Pa	ges Etc)		
							menos.	
	C.T. Angelis, C.A. Dimitriadis, M. Miyasaka, F.V. Farmakis, G. Kamarinos, J. Brini and J. Stoemenos, "Effect of Excimer Laser Annealing on the Structural and Electrical Properties of Polycrystalline Silicon							
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Examiner Date Considered

EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant